

RECEIVED
CENTRAL FAX CENTER

JUL 17 2006

FACSIMILE COVER SHEET

SALIWANCHIK, LLOYD & SALIWANCHIK

A Professional Association

P.O. Box 142950

Gainesville, FL 32614-2950

Telephone (352) 375-8100

Facsimile (352) 372-5800

The information contained in this facsimile message is intended only for the personal and confidential use of the designated recipients named below. This message may be an attorney-client communication, and as such is privileged and confidential. If the reader of this message is not the intended recipient or an agent responsible for delivering it to the intended recipient, you are hereby notified that you have received this document in error, and that any review, dissemination, distribution, or copying of this message is strictly prohibited. If you have received this communication in error, please notify us immediately by telephone and return the original message by mail. Thank you.

TO: Examiner Quovaunda Jefferson
ART UNIT 2823

FAX NO.: (571)-273-8300

FROM: Francene Stewart

DATE: July 17, 2006

NO. OF PAGES (INCLUDING COVER SHEET): 6

SUBJECT/MESSAGE:

Re: U.S. Patent Application Serial No. 10/757,821; filed January 15, 2004
METHOD OF MAKING A MONITORING PATTERN TO MEASURE A DEPTH AND A PROFILE
OF A SHALLOW TRENCH ISOLATION
(Kang)
Attorney Docket No. SUN-DA-138T

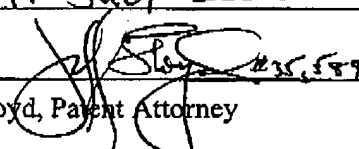
Attachment: Amendment Under 37 CFR §1.111 (5 pages)

**OFFICIAL COMMUNICATION PLEASE DELIVER
IMMEDIATELY**

If you do not receive all pages or if any transmission is not legible, call the sender at (352)375-8100.

**RECEIVED
CENTRAL FAX CENTER****JUL 17 2006**

I hereby certify that this correspondence is being
facsimile transmitted to the United States Patent and
Trademark Office on the date shown below:

17 July 2006
Jeff Lloyd, Patent Attorney

AMENDMENT UNDER 37 C.F.R. § 1.111
Examining Group 2823
Patent Application
Docket No. SUN-DA-138T
Serial No. 10/757,821

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Examiner : Quovaunda Jefferson
Art Unit : 2823
Applicant : Jung Ho Kang
Serial No. : 10/757,821
Filed : January 15, 2004
Confirm. No. : 5400
For : A Method of Making a Monitoring Pattern to Measure a Depth and a Profile
of a Shallow Trench Isolation

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT UNDER 37 C.F.R. §1.111

Sir:

In response to the Office Action dated April 17, 2006, please amend the application referred
to above as follows: